



IFW 1723  
PATENT APPLICATION

IN THE U.S. PATENT AND TRADEMARK OFFICE

Applicant : Mikio SUGIMOTO

Title : MANUFACTURING METHOD OF METAL ION WATER,  
WATER TREATMENT METHOD USING THE MANUFACTURING METHOD,  
MANUFACTURING DEVICE OF METAL ION WATER, AND  
WATER TREATMENT APPARATUS USING THE MANUFACTURING DEVICE

Serial No.: 10/567 707 Group: 1723

Confirmation No.: 3892

Filed : February 7, 2006 Examiner: Unknown

International Application No.: PCT/JP2004/011721

International Filing Date : August 9, 2004

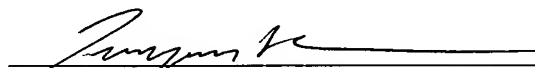
Atty. Docket No.: 4900.P0056US

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

**FIRST CLASS MAILING CERTIFICATE**

Sir:

I hereby certify that this correspondence is being deposited with the United States Postal Service under 37 CFR 1.8 as first class mail in an envelope addressed to: Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450, on September 11, 2006.

  
Terryence F. Chapman

TFC/smd

FLYNN, THIEL, BOUTELL	Dale H. Thiel	Reg. No. 24 323
& TANIS, P.C.	David G. Boutell	Reg. No. 25 072
2026 Rambling Road	Terryence F. Chapman	Reg. No. 32 549
Kalamazoo, MI 49008-1631	Mark L. Maki	Reg. No. 36 589
Phone: (269) 381-1156	Liane L. Churney	Reg. No. 40 694
Fax: (269) 381-5465	Brian R. Tumm	Reg. No. 36 328
	Steven R. Thiel	Reg. No. 53 685
	Donald J. Wallace	Reg. No. 43 977
	Sidney B. Williams, Jr.	Reg. No. 24 949

Correspondence: Letter to Patent Office  
dated September 11, 2006  
including enclosures listed thereon

190.05/05



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MANUFACTURING DEVICE OF METAL ION WATER, AND  
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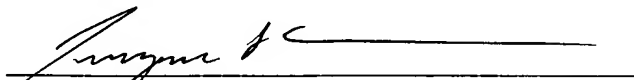
Commissioner for Patents  
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Alexandria, VA 22313-1450

**LETTER TO PATENT OFFICE**

Sir:

Enclosed herewith is a Supplemental Oath or Declaration for the present application in which the correct foreign priority information for the present application is contained therein. Also enclosed herewith are certified copies of the foreign priority applications. Favorable consideration is respectfully solicited.

Respectfully submitted,

  
Terryence F. Chapman

TFC/smd

FLYNN, THIEL, BOUTELL  
& TANIS, P.C.  
2026 Rambling Road  
Kalamazoo, MI 49008-1631  
Phone: (269) 381-1156  
Fax: (269) 381-5465

Dale H. Thiel	Reg. No. 24 323
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Encl: Supplemental Declaration (1)  
Certified copies of Foreign Priority Documents (4)  
Postal Card

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